



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
www.uspto.gov

BIBDATASHEET

Bib Data Sheet

CONFIRMATION NO. 3652

SERIAL NUMBER 10/791,810	FILING DATE 03/04/2004 RULE	CLASS 355	GROUP ART UNIT 2851	ATTORNEY DOCKET NO. 109325.01
-----------------------------	---------------------------------------	--------------	------------------------	-------------------------------------

APPLICANTS

Yuji Imai, Saitama, JAPAN;

**** CONTINUING DATA *******

This application is a DIV of 09/839,202 04/23/2001 PAT 6,737,207

HJ

**** FOREIGN APPLICATIONS *******

JAPAN 2000-124506 04/25/2000

HJ

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 05/20/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWING	TOTAL CLAIMS	INDEPENDENT CLAIMS
Verified and Acknowledged	Examiner's Signature HJ	JAPAN	10	12	2

ADDRESS

25944
 OLIFF & BERRIDGE, PLC
 P.O. BOX 19928
 ALEXANDRIA , VA
 22320

TITLE

Method for evaluating lithography system, method for adjusting substrate-processing apparatus, lithography system, and exposure apparatus

FILING FEE RECEIVED 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
-----------------------------------	---	---